

APPROVED	O.G. FIG.
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DRAFTSMAN	

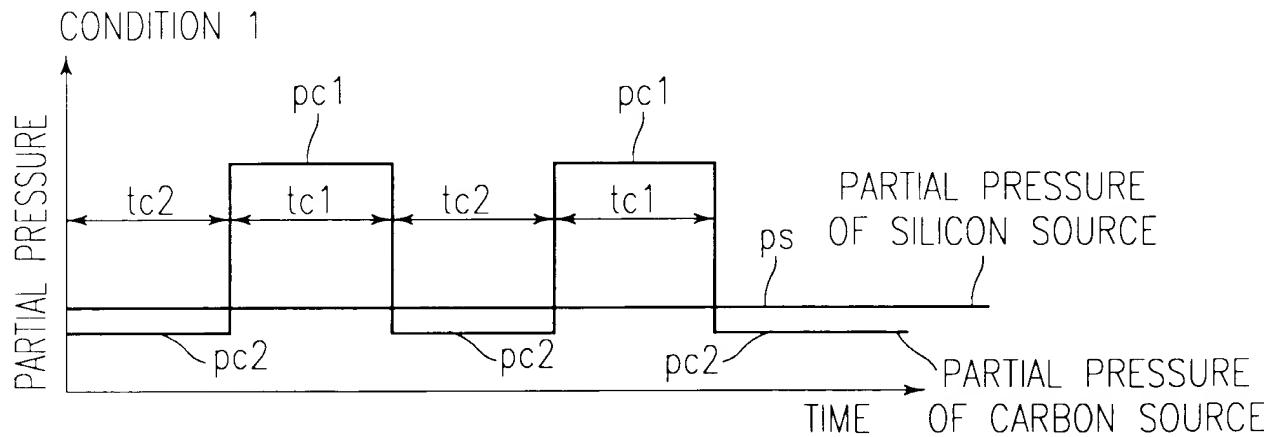


FIG. 1

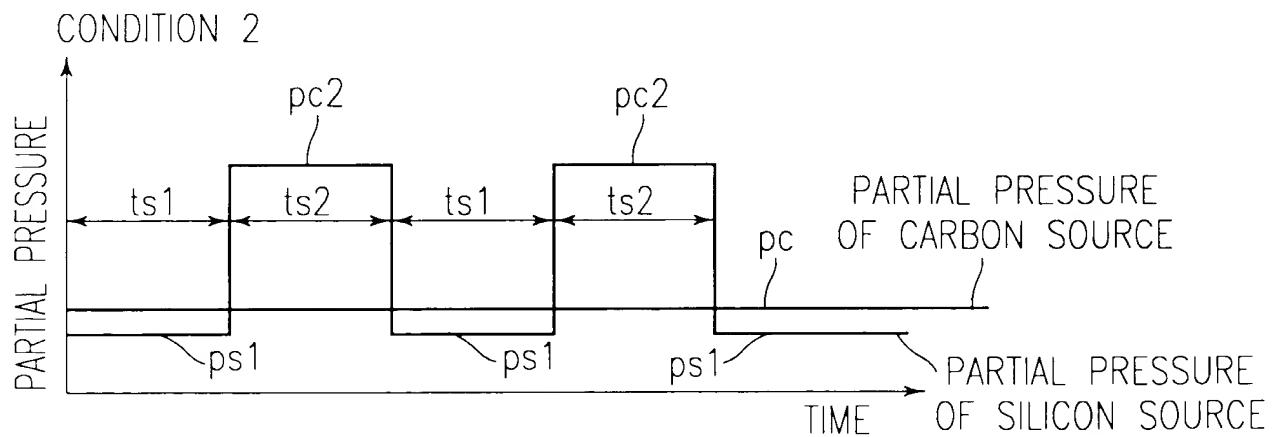
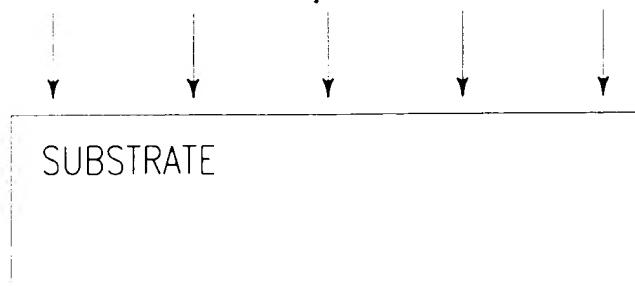


FIG. 2

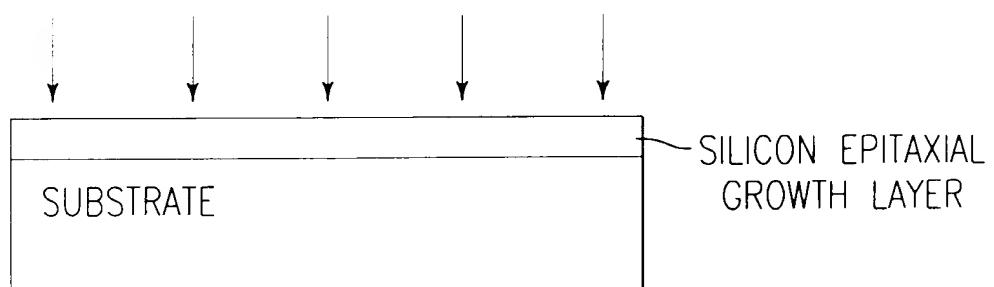
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SILICON SOURCE



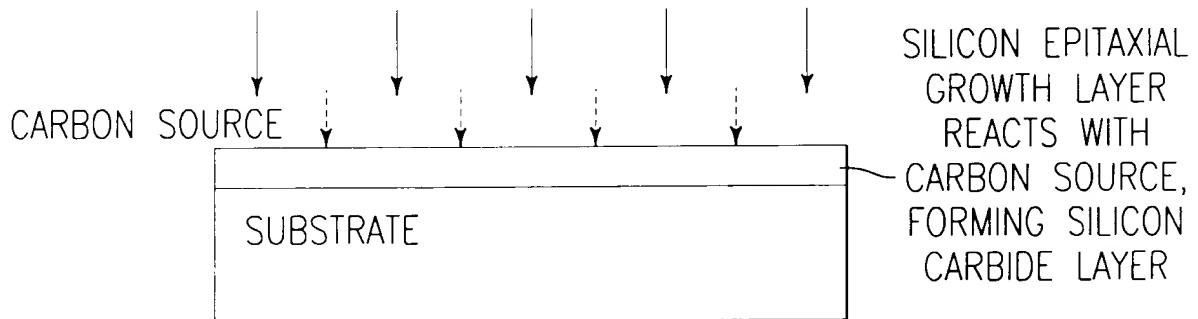
*FIG. 3A*

SILICON SOURCE



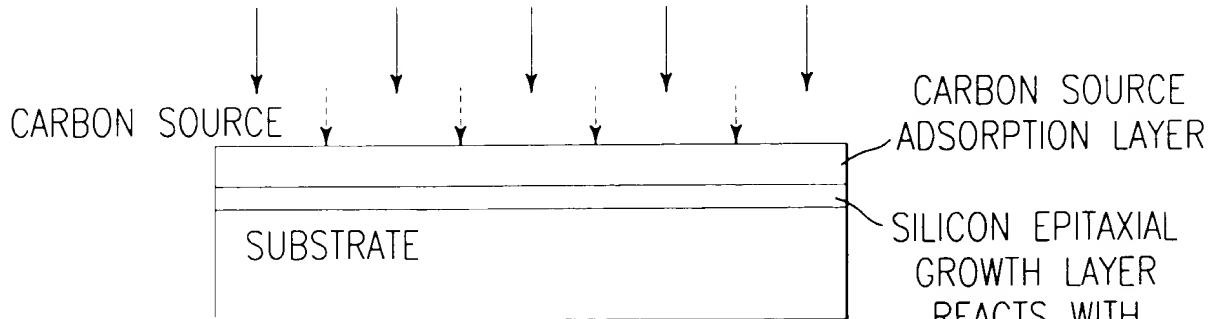
*FIG. 3B*

SILICON SOURCE



*FIG. 3C*

SILICON SOURCE



*FIG. 3D*

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FIG. 4

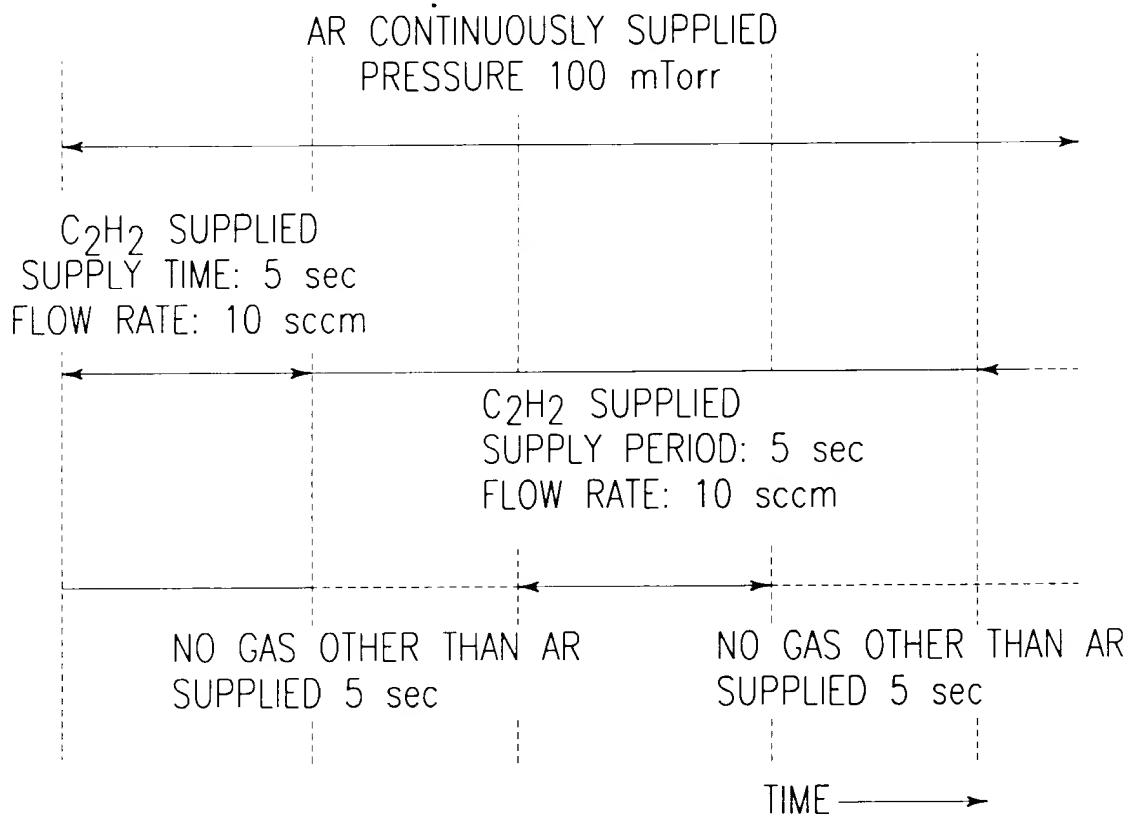
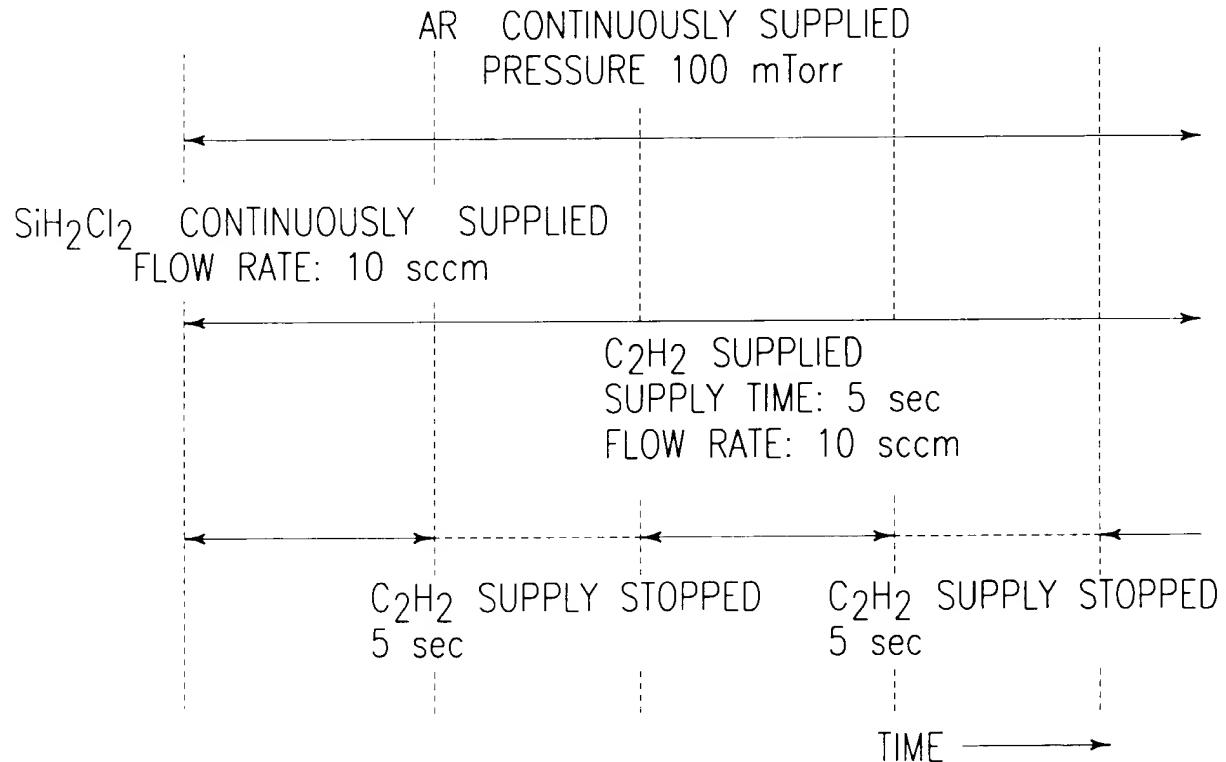
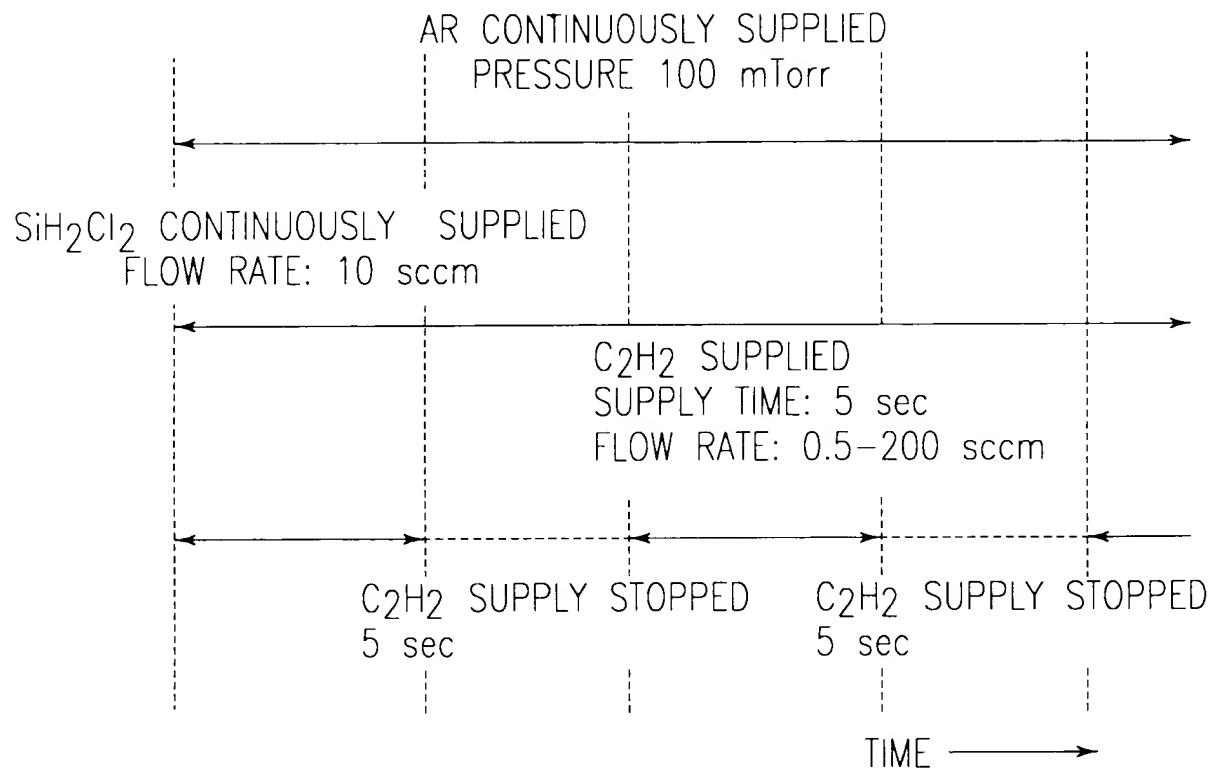


FIG. 5

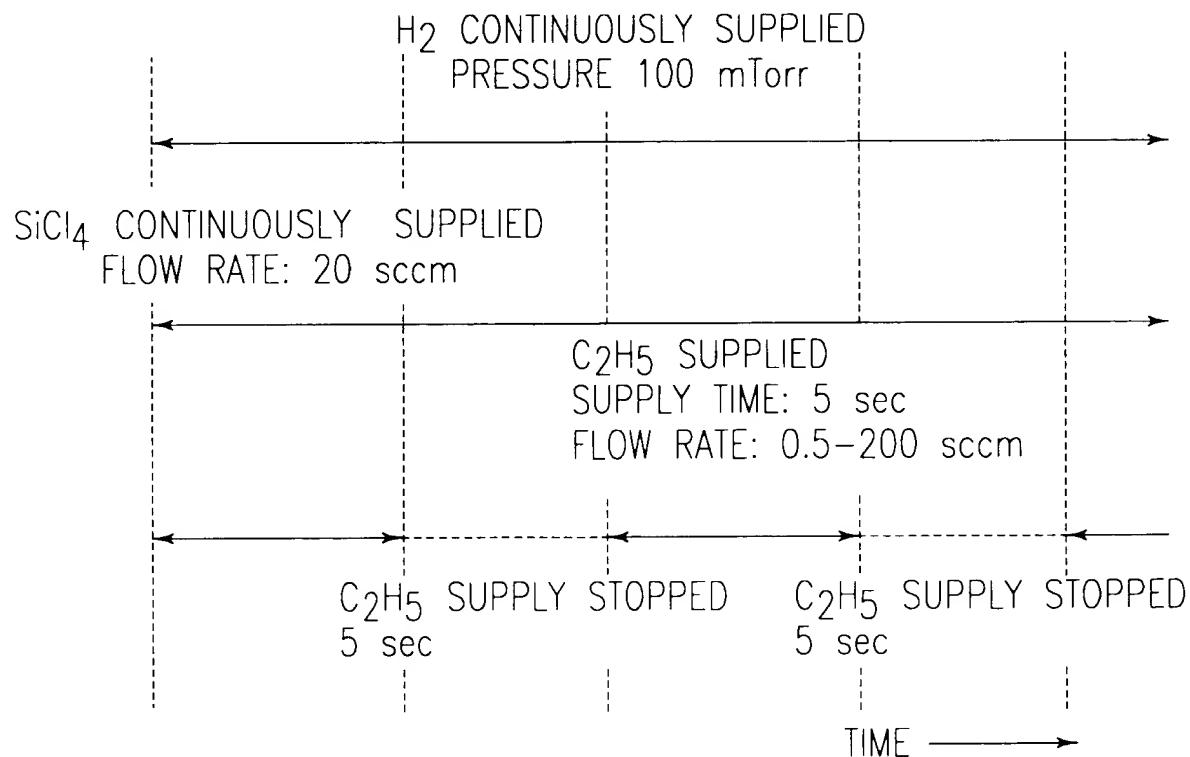


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**FIG. 6**

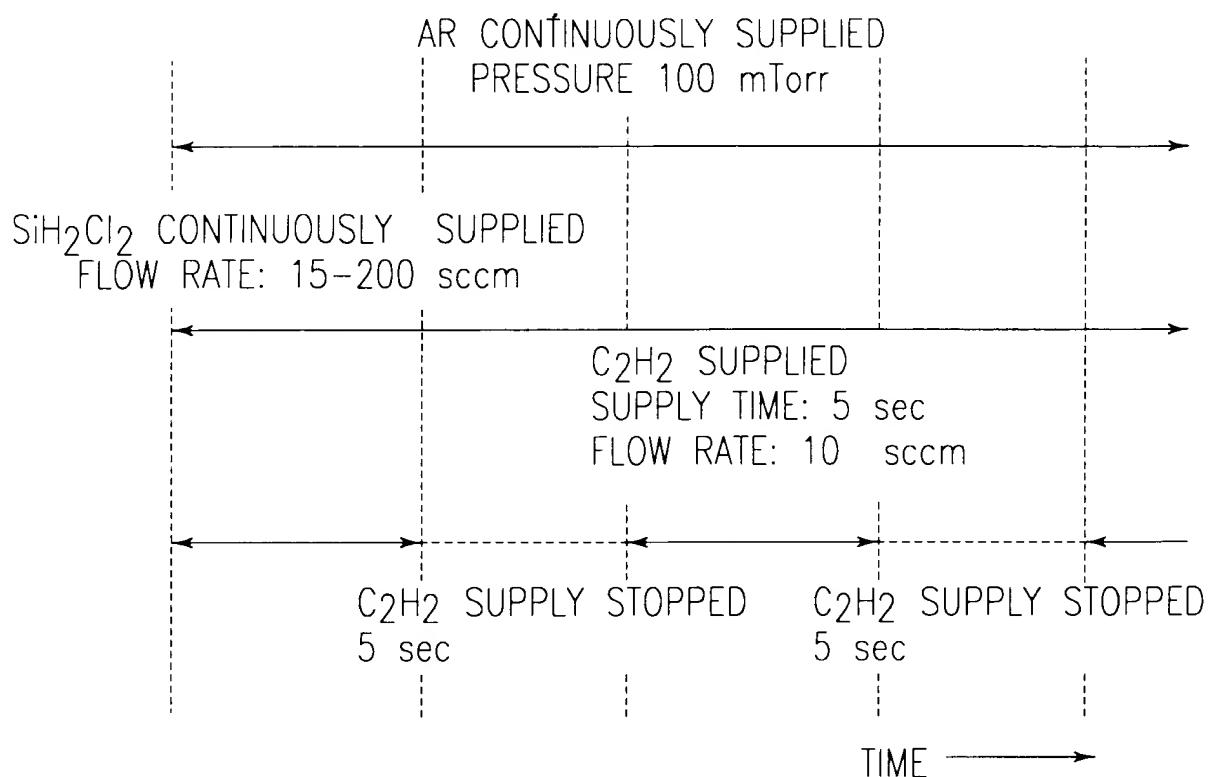


**FIG. 7**

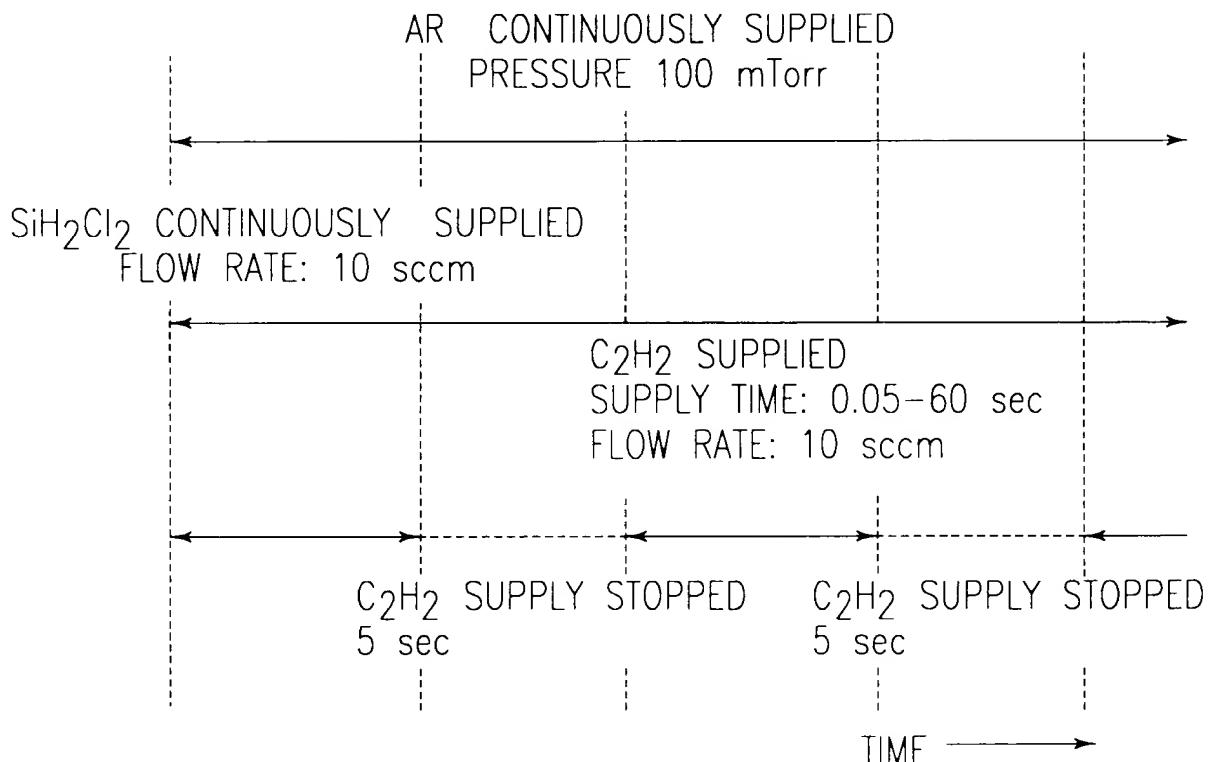


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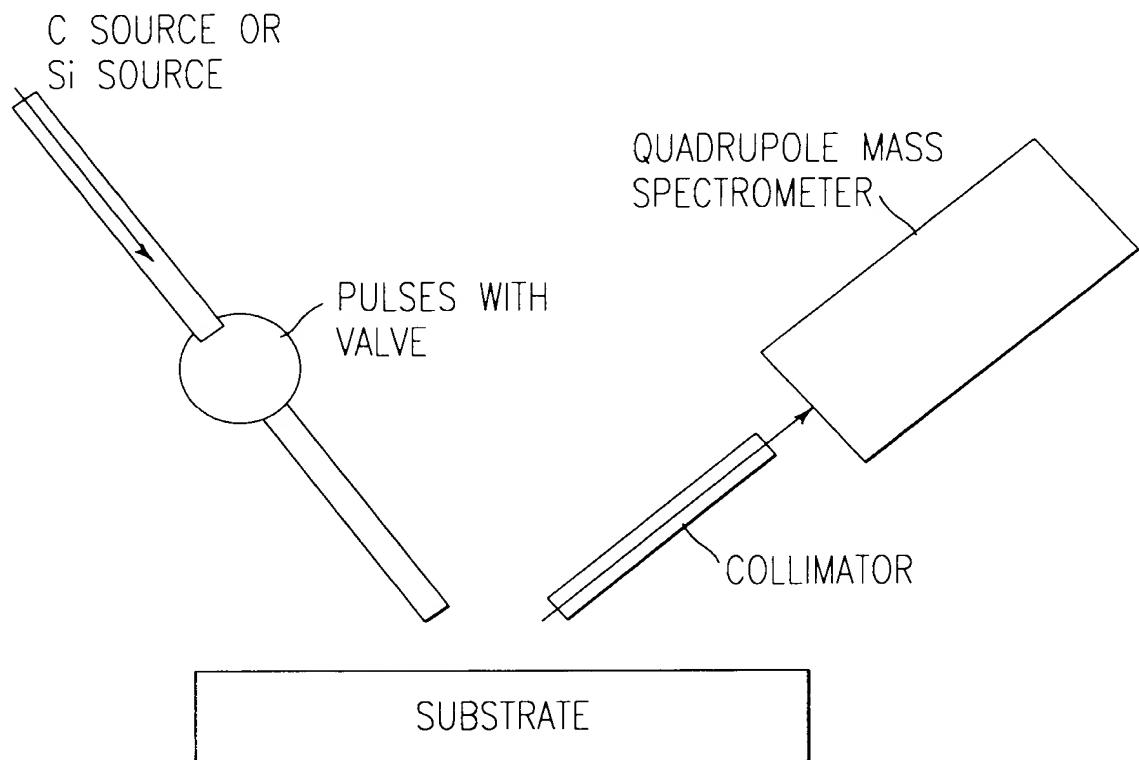
*FIG. 8*



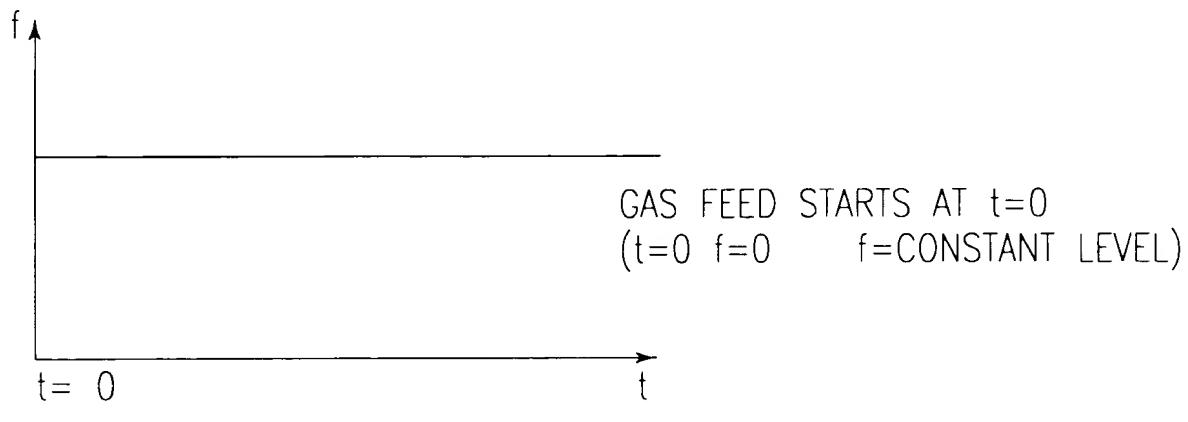
*FIG. 9*



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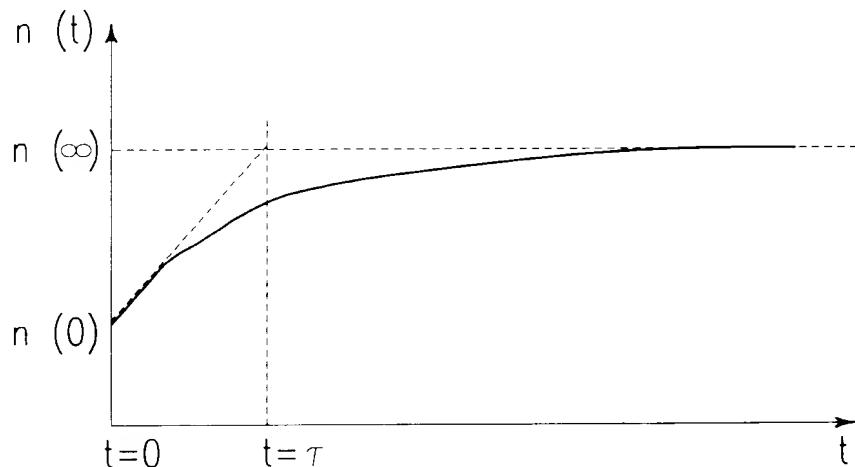


*FIG. 10*



*FIG. 11*

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CHANGE OVER TIME (RELATIVE VALUE) OF  
NUMBER OF MOLECULES DESORBED FROM  
SUBSTRATE AS MEASURED BY QUADRUPOLE  
MASS SPECTROMETRY

*FIG. 12*